



Birla Institute of Technology

Mesra, Ranchi-835 215

Department of Physics

Walk in Interview for Project Associate-I / Research student

Title of the Project : **Optimization of Chemical Vapor Deposition (CVD) growth conditions for defect free large crystallite 2D-semiconductors and their hetro-structures for Opto-electronic applications.**

Funding Agency : UGC-DAE Consortium for Scientific Research

No of Post : 01 (One)

Fellowship : a) M.Sc Physics with GATE / NET-JRF may be appointed as Project Associate-I with remuneration Rs 31,000/- PM + HRA for initially 01 Year.

b) If NET /GATE qualified candidate is not available then M.Sc Physics candidate can be selected as Research student with a monthly remuneration of Rs 14000/- PM +HRA for initially for a period of 01 Year.

Project is tenable for extension up to 03 Years.

Tenure : 01 Year.

Eligibility : M. Sc. in Physics / Applied Physics with at least 60% marks

**Date and time of Interview: 10/06/2022, 9:30 am at Dept. of Physics.**

Interested candidate may appear for the walk-in interview on the date and time mentioned above to be held in the Department of Physics, Birla Institute of Technology, Mesra, Ranchi - 835215. Candidates are required to bring their application, updated resume and self-attested copy of certificates during the interview. Applicant may send their advance copy of application and resume by e-mail to [dilipsinghnano1@bitmesra.ac.in](mailto:dilipsinghnano1@bitmesra.ac.in) (Dr. Dilip K. Singh, PI). No TA/DA will be provided for attending the interview. Successful candidate may enrol for Ph. D program of the institute if they qualify the entrance test for the same.

Registrar